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**PATENT APPLICATION**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Date December 2, 2002

In re the Application of

Yasushi YAMAZAKI et al.

Group Art Unit: 2811

Application No.: 09/970,766

Examiner: Shouxiang He

Filed: October 5, 2001

Docket No.: 110791

For: METHOD OF MANUFACTURING SEMICONDUCTOR SUBSTRATE, SEMICONDUCTOR SUBSTRATE, ELECTRO-OPTICAL APPARATUS AND ELECTRONIC EQUIPMENT

**LARGE ENTITY PETITION FOR 1<sup>st</sup> - 3<sup>rd</sup> EXTENSION  
OF TIME UNDER 37 C.F.R. §1.136(a) AND  
TRANSMITTAL OF FEE UNDER 37 C.F.R. §1.17**

Director of the U.S. Patent and Trademark Office  
Washington, D.C. 20231

Sir:

Transmitted herewith is a response to the outstanding Official Action in the above-identified patent application. The shortened statutory period having expired October 31, 2002, an extension of time for a period of one month is hereby requested. Attached hereto is our Check No. 136764 in the amount of \$110.00 in payment for:

Extension fee for response within first month pursuant to §1.136(a) (\$110.00)  
 Extension fee for response within second month pursuant to §1.136(a) (\$400.00)  
 Extension fee for response within third month pursuant to §1.136(a) (\$920.00)

The Director is hereby authorized to charge any additional fee or credit any overpayment associated with this communication to Deposit Account No. 15-0461. Two copies of this petition are enclosed.

Respectfully submitted,

James A. Oliff  
Registration No. 27,075

Eric D. Morehouse  
Registration No. 38,565

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OLIFF & BERRIDGE, PLC  
P.O. Box 19928  
Alexandria, Virginia 22320  
Telephone: (703) 836-6400

**DEPOSIT ACCOUNT USE  
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